

United States Patent and Trademark Office

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Virginia 22313-1450 www.uspto.gov

APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/522,569	11/17/2005	Shuhei Ogawa	033082M239	033082M239 8765	
441	7590 07/06/2006		EXAM	EXAMINER	
SMITH, GAMBRELL & RUSSELL 1850 M STREET, N.W., SUITE 800			OLSEN, A	OLSEN, ALLAN W	
WASHINGTON, DC 20036			ART UNIT	PAPER NUMBER	
	,		1763		
			DATE MAILED: 07/06/2006	DATE MAILED: 07/06/2006	

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application No.	Applicant(s)					
		10/522,569	OGAWA ET AL.					
•	Office Action Summary	Examiner	Art Unit					
		Allan Olsen	1763					
	- The MAILING DATE of this communication appears on the cover sheet with the correspondence address - Period for Reply							
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS, WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication. - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).								
Status								
1)⊠	Responsive to communication(s) filed on 17 No	ovember 2005.						
2a) <u></u> □	This action is FINAL . 2b)⊠ This action is non-final.							
3)	··							
	closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213.							
Disposit	ion of Claims							
4)⊠	Claim(s) 1-13 is/are pending in the application.							
	4a) Of the above claim(s) is/are withdrawn from consideration.							
5)□	is/are allowed.							
-	Claim(s) <u>1-13</u> is/are rejected.			•				
• -	Claim(s) is/are objected to.	I Attack						
8)[_]	Claim(s) are subject to restriction and/o	r election requirement.						
Applicat	ion Papers							
9) The specification is objected to by the Examiner.								
10)⊠	10)⊠ The drawing(s) filed on <u>17 November 2005</u> is/are: a)⊠ accepted or b)☐ objected to by the Examiner.							
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).								
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).								
11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.								
Priority (under 35 U.S.C. § 119							
12)⊠ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a)⊠ All b)□ Some * c)□ None of:								
	1. Certified copies of the priority documents have been received.							
	2. Certified copies of the priority documents have been received in Application No							
	3. Copies of the certified copies of the prior		ed in this National	Stage				
* (application from the International Bureau (PCT Rule 17.2(a)).							
* See the attached detailed Office action for a list of the certified copies not received.								
Attachmer								
1) Notice of References Cited (PTO-892) 4) Interview Summary (PTO-413) Paper No(s)/Mail Date								
3) Infor	(PTO-152) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) 5) ☐ Notice of Informal Patent Application (PTO-152)							
Paper No(s)/Mail Date 11/17/05. 1-28 - 0 5 6) Other:								

Application/Control Number: 10/522,569

Art Unit: 1763

DETAILED ACTION

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

Claims 1-13 are rejected under 35 U.S.C. 103(a) as being unpatentable over US Patent 6,326,302 (Joubert) in view of US Patent 6,869,542 (Desphande) and further in view of US Patent 6,069,090 (Eriguchi).

Joubert teaches using an etchant comprising O2 and NH3 etch an organic layer with an overlying SiO2 hard mask.

Joubert does no teach using a Si-containing organic material as the overlying hard mask. Joubert does not teach the residence time of plasma species within the

Application/Control Number: 10/522,569

Art Unit: 1763

plasma zone. Joubert does not teach controlling the CD shift by adjusting the ratio of O2 and NH3.

Desphande teaches using a Si-containing organic material as a hard mask when etching an underlying organic material.

Eriguchi teaches that CD shift can be controlled by controlling the flow rates of plasma gases.

It would have been obvious to one skilled in the art to incorporate the hard mask of Desphande into the process of Joubert because Desphande teaches that Sicontaining hard masks sputter less readily than SiO2 and they offer tighter CD control than conventional hard masks (column 5, lines 1-57).

It would have been obvious to one skilled in the art to optimize the flow rates of O2 and NH3 according to Eriguchi and in so doing the O2 to NH3 ratio and the plasma residence time would also be optimized.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Allan Olsen whose telephone number is 571-272-1441. The examiner can normally be reached on M, W and F: 1-5.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Parviz Hassanzadeh can be reached on 571-272-1435. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Application/Control Number: 10/522,569

Art Unit: 1763

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Alla Olsan

Allan Olsen

Primary Examine